The PANDA MVD





Helmholtz International Center



Hans-Georg Zaunick II. Physikalisches Institut, JLU Gießen





The PANDA Detector @ FAIR



The Micro-Vertex Detector



- 2 barrel pixel layers
- 4 pixel disks
- 2 barrel strip layers
- 2 mixed disks
- 2 optional forward wheels (@40 & 60 cm)

Benchmark Channels

open charm: e.g. $\overline{p}p \rightarrow D^{\dagger}D^{\cdot} \rightarrow K^{\cdot}\pi^{\dagger}\pi^{\dagger}K^{\dagger}\pi^{\cdot}\pi^{\cdot}$

PANDARoot Simulations with detailed detector descriptions



Benchmark Channels

open charm: e.g. $\overline{p}p \rightarrow D^0\overline{D}^0 \rightarrow K_s\pi^*\pi^-K^*\pi^-$



Pixel Subdetector - Sensors



NIMA 594 (2008) p.29



INFN Torino

Epitaxial silicon pixel sensors

- Several thicknesses evaluated, 100 μm chosen for PANDA
- 100 x 100 μ m² pixel array
- Full qualification of prototypes done
- Full size PANDA geometry

Pixel Subdetector - Modules







INFN Torino



Pixel Subdetector - Front-end

INFN Torino



ToPix v2

- Torino Pixel Readout Chip, current version V3
- 2 x 128 + 2 x 32 double columns
- size 4 x 4.5 mm²
- Complete pixel cells with full column architechture, end-of-column logic and buffers
- Fully tested in lab and beam setups
- Next prototype ToPix v4 submitted, lab tests pending



ToPix v3

NIMA 596 (2008) p.96

Strip Subdetector - Setup



Strip Subdetector – Barrel Stave



Stave prototypes



ZEA Jülich

- Ultralight carbon foam moulded in carbon fiber form sheet reinforcements
- Integrated cooling pipe in more recent prototypes



Stave prototypes

Folding of PCB around stave to connect n-side and p-side r/o



1st prototyping run (CiS Erfurt) 2010 2nd prototyping run (CiS Erfurt) 2013



Silicon Strip Sensor Prototypes

- Full size PANDA geometry
- 285 µm thickness
- Strip pitches of 65 and 50 μm (barrel sensors)
- 67.5 μm pitch for trapezoidal fw sensors
- Punch-through biased and poly-Si biased



Sensor Probing and Prototype Assembly



Many sensor characterization capabilities available



"Probecard": fixed sensor assembly with all strips bonded to common lines (top and bottom) 20 Feb 2014 HG Zaunick **Probe Station**





Wafer diode test fixture



- All relevant parameters have to be monitored for QA
- → full sensor characterization required
- Analysis of irradiated sensors (p/n-irradiation)





20 Feb 2014 HG Zaunick

- All relevant parameters have to be monitored for QA
- \rightarrow full sensor characterization required
- Analysis of irradiated sensors (p/n-irradiation)





Irradiation with 14MeV Protons (Cyclotron Bonn)



Typical profile of hadronic lattice damage



20 Feb 2014 HG Zaunick

Flex PCBs



20 Feb 2014 HG Zaunick

Assembly of Prototype Sensors



Prototypes



APV25 Front-ends

Prototypes



Prototypes





Very successfully tested in testbeams @ COSY











Strip Frontend



Module Data Concentrator



Infrastructure - Readout

Thin Al-cables

- Thin kapton carrier
- Aluminum strips, 18 diff. pairs
- For data transmission out of the MVD
- Connect FEs/MDC to GBT receiver
- 320 Mbit/s serial links



GBT Project

20 Feb 2014 HG Zaunick

- E-link interface to on-detector node
- Optical link to the off-detector side



Infrastructure - Powering

DC-DC powering concept

- Air-coil converters operate inside strong magnetic fields
- >80% efficiency
- Converter developed at CERN for LHC upgrade





AMIS5MP DC/DC converter

20 Feb 2014 HG Zaunick



FE-n-D

Infrastructure - Cooling

- Water cooling system in depression mode
- Operating at room temperature
- Carbon foam embedded in staves: high thermal conductivity
- Dummy staves w/ thermal loads built up and scrutinized



Customized Thermal Test Resistors

20 Feb 2014 HG Zaunick

Numbers

- Number of sensors:
- Number of FEs:
- Number of channels:
- Number of DC-DC:
- Active area (m²):
- Cables off MVD:
- Cable cross section:
- Power dissipation:



